

Date: 2014-08-18

Volfoni R&D 29 Rue Jean-Jacques Rousseau 75001 PARIS FRANCE

Dear Sirs,

Re.: Letter of Appointment

This is the letter of authorization to accept our appointment of <u>The Hong Kong Standards and Testing Centre Ltd. Mr. KC Lee</u> as agent for VOLFONI R&D, 29 Rue Jean-Jacques Rousseau, 75001 Paris, FRANCE to sign applications before the Commission on our behalf, to make representations to you on our behalf, and to receive and exchange data between our company and the Commission in connection with Certification of the following product of VOLFONI R&D.

Product name : ActivHub RF50 RF emitter

Model : VPES-04100

This authorization will expire one year from the date of this letter.



Denis DANE System engineer